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09/843,582

LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicant(s):

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Filing Date:

04/26/01

Group:

3723

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
<i>bvn</i>	AA	5,861,066/	01/19/1999	Moinpour et al.			
	AB	5,868,857/	02/09/1999	Moinpour et al.			
	AC	5,954,997/	09/21/1999	Kaufman et al.			
	AD	6,194,317/	02/27/2001	Kaisaki et al.			
	AE	6,234,875/	05/22/2001	Pendergrass, Jr.			
	AF	6,290,780/	09/18/2001	Ravkin			
	AG	6,319,096/	11/20/2001	Mueller et al.			
	AH	6,416,685/	07/09/2002	Zhang et al.			
	AI						
	AJ						
	AK						

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TECHNOLOGY CENTER R3700

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	
	AS	
	AT	

Examiner

Date Considered

Dung van Nguyen

4-9-2003

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.